



Stacked XYZ Stage



Features

- Stacked 3-axis stage with orthogonality design
- Global flatness and straightness up to to sub-µm level
- X/Y axis
 High stiffness, high precision guide
 Consistent design of cable disturbing force
- Z-axis

Vertical magnetic levitation gravity compensation for high positioning accuracy
High stiffness, high precision guide
Vertical incremental encoder for up to 5nm resolution
Ultra-thin, lightweight design
Vertical mechanical travel up to 30mm

Description

The stage adopts modularization, ultra-thin, orthogonality design, the MZM200-10 Stage standard module is integrated on top of the cross platform L2S125 for high precision, high stiffness linear motion of X, Y and Z axis with 3 degrees of freedom.

The MZM200-10 uses the large-stroke maglev gravity compensation technology, which has the function of reducing the load of the vertical motor and greatly improving the vertical motion performance and lifetime. High-precision up-and-down positioning is possible.

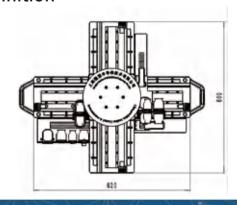
The L2S125 adopts integration, orthogonality design with a compact, low-profile. High-precision, high-stiffness linear motion in horizontal X/Y axis with 2 degrees of freedom.

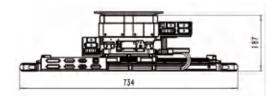
Applications

- Wafer production control applications such as: thin film metrology and critical dimension metrology
- Wafer scribing

■ Wafer laser thermal annealing

Interface Definition





^{*}Interface dimensions from L3S190 in the upper limit



Technical Specifications

| | | L3S190-350 | |
|-------------------------------|---|------------|---------------------|
| Axes name | X | Υ | Z |
| Travel range | 350 mm | 350 mm | 9 mm (customizable) |
| Max. velocity | 0.6 m/s | 0.6 m/s | 0.1 m/s |
| Max. acceleration | 5 m/s^2 | 5 m/s^2 | 2 m/s^2 |
| Accuracy_indicative value | ±20 μm | ±20 μm | - |
| Accuracy_calibration value | ±2 μm | ±2 μm | ±0.5 μm |
| Bidirectional repeatability | ±1 μm | ±1 μm | ±1μm ±0.3μm/1mm |
| Straightness | ±10 μm | ±10 μm | - |
| Pitch | ±75 arcsec | ±50 arcsec | ±50 arcsec |
| Roll | - | - | ±50 arcsec |
| Yaw | ±75 arcsec | ±75 arcsec | - |
| Orthogonality | 5 μ | 5 μm | |
| Mechanical properties | | | |
| Moving mass (without payload) | 14.2 Kg | 27.5 Kg | 6.7 Kg |
| Max. load | 5 Kg | | |
| Stage mass | 40 Kg | | |
| Dimensions | 734 mm×600 mm×187 mm (vertical upper limit) | | |

Customization Information

The series is configured with options that can be selected based on the user's actual application. Options include encoders, guide, and more.

Table 1 Encoder Options

| -S1 | Incremental analog optical linear encoder, 1Vpp |
|-----|---|
| -S2 | Incremental digital optical linear encoder, TTL |
| -S3 | Absolute optical linear encoder, BISS |

Table 2 Guide Options

| -G1 | High-stiffness mechanical guide |
|-----|------------------------------------|
| -G2 | High-performance air-bearing guide |